IN THE CLAIMS:

The following is a complete listing of the claims in this application, reflects all changes currently being made to the claims, and replaces all earlier versions and all earlier listings of the claims:

- 1. (Currently Amended) A forming method [[of]] <u>for forming</u> an ink jet print head substrate in which an ink flow path forming member is attached <u>onto to</u> a substrate for forming an ink discharge pressure generating element, wherein a <u>minute</u> pit is formed <u>on in</u> an attachment region of <u>said the</u> substrate for attaching <u>said the</u> liquid flow path forming member.
- 2. (Currently Amended) The forming method of an ink jet print head substrate according to claim 1, wherein said minute the pit is formed by anisotropic etching.
- 3. (Currently Amended) The forming method of an ink jet print head substrate according to claim 2, wherein at least a part of an etching mask for said the anisotropic etching performed using an etching mask at least a part of which is made of polyether amide resin.
- 4. (Currently Amended) The forming method of an ink jet print head substrate according to claim 3, wherein said the polyether amide resin layer also serves as an adhering layer between said the substrate and said the liquid flow path forming member.

- 5. (Currently Amended) An ink jet print head substrate formed by a forming the method of an ink jet print head substrate according to any one of claims 1 to 4.
- 6. (Currently Amended) A manufacturing method [[of]] <u>for making</u> an ink jet print head using an ink jet print head substrate formed <u>by a forming using the</u> method <u>of an ink jet print head substrate</u> according to any one of claims 1 to 4, wherein a discharge port of discharging ink, a liquid path communicating with <u>said the</u> discharge port and also including <u>said the</u> ink discharging pressure generating element, a liquid flow path forming member attached with <u>said the</u> substrate to form <u>said the</u> liquid path are formed on <u>said the</u> substrate.
- 7. (Currently Amended) The manufacturing method of an ink jet print head according to claim 6, wherein said minute the pit is formed in close proximity to both ends of a longitudinal direction in said the ink jet print head.
- 8. (Currently Amended) An ink jet print head manufactured by a <u>using</u>
 the manufacturing method of an ink jet print head according to claim 6.